



Form PTO-1449

**INFORMATION DISCLOSURE CITATION
IN AN APPLICATION**

(Use several sheets if necessary)

PATENT DOCKET NO.
0649-0780PAPPLICATION NO.
09/837,386APPLICANT
Takatoshi HIBIFILING DATE
April 19, 2001GROUP
2614**U.S. PATENT DOCUMENTS**

| EXAMINER INITIAL | DOCUMENT NUMBER | Kind | DATE | NAME | CLASS | SUB CLASS | FILING DATE IF APPROPRIATE |
|---------------------|-----------------|------|------|------|-------|--------------|-------------------------------|
| | US | | | | | | |
| | US | | | | | | |
| | US | | | | | | |
| | US | | | | | | |
| | US | | | | | | |
| | US | | | | | | |
| | US | | | | | | |
| | US | | | | | | |
| | US | | | | | | |
| | US | | | | | | |

RECEIVED

DEC 18 2003

Technology Center 2600

FOREIGN PATENT DOCUMENTS

| | Office | DOCUMENT NUMBER | Kind | DATE | COUNTRY | CLASS | SUB CLASS | TRANSLATION | |
|--|--------|--------------------|------|------------|---------|-------|--------------|-------------|----|
| | | | | | | | | YES | NO |
| | CN | 1007401 | B | 1990-03-28 | CHINA | | | Abs | |
| | CN | 1093848 | A | 1994-10-19 | CHINA | | | Abs | |
| | CN | 1195946 | A | 1998-10-14 | CHINA | | | Abs | |
| | | | | | | | | | |
| | | | | | | | | | |
| | | | | | | | | | |
| | | | | | | | | | |
| | | | | | | | | | |
| | | | | | | | | | |

OTHER DOCUMENTS

(Include Name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.)

EXAMINER

Leon W. Desix

DATE CONSIDERED

12/27/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.